

### DC TO 25 GHz GaAs SPDT SWITCH

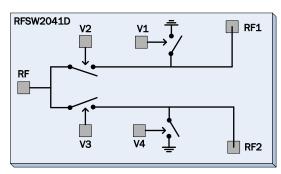
Package: Die, 1.91mmx2.11mmx0.10mm



### **Product Description**

RFMD's RFSW2041D is a reflective SPDT GaAs microwave monolithic integrated circuit (MMIC) switch designed using the RFMD FD05  $0.5 \, \mu m$  switch process. The RFSW2041D is developed for broadband communications, instrumentation, and electronic warfare.





### **Features**

- Low Insertion Loss: 1.1dB at 20GHz
- High Isolation: 45 dB at 20 GHz
- Excellent Return Loss
- 20nS Switching Speed
- GaAs pHEMT Technology

# **Applications**

- Broadband Communications
- Test Instrumentation
- Fiber Optics
- Military
- Aerospace

Parameter	Specification		Unit	Condition		
raiametei	Min.	Min. Typ. Max.		UIIIL	Condition	
Operating Frequency	DC		25	GHz		
Insertion Loss (OGHz to 5GHz)		0.9	1.4	dB	ON State	
Insertion Loss (5 GHz to 10 GHz)		0.8	1.6	dB	ON State	
Insertion Loss (10 GHz to 15 GHz)		0.9	1.7	dB	ON State	
Insertion Loss (15GHz to 20GHz)		1.1	1.9	dB	ON State	
Insertion Loss (20GHz to 25GHz)		1.4		dB	ON State	
Isolation (DC to 5 GHz)	41	50		dB	ON State (Measured at Inactive Port)	
Isolation (5GHz to 25GHz)	36	43		dB	ON State (Measured at Inactive Port)	
Isolation (DC to 5GHz)	36	44		dB	OFF State	
Isolation (5GHz to 25GHz)	32	35		dB	OFF State	
Input Return Loss (DC to 25 GHz)	14	15		dB	ON State	
Output Return Loss (DC to 25 GHz)	11	13		dB	ON State	
IIP3	34	39		dBm	100 MHz spacing 2 dBm input	
IIP2	62	67		dBm	100 MHz spacing 2 dBm input	
Switching Speed		20	25	ns	50% control to 90% RF	
Control Current		30	50	uA	Sum of all control lines	
Control Voltage	-3	-5	-8	$V_{DC}$		



### **Absolute Maximum Ratings**

Parameter	Rating	Unit
Drain Bias Voltage (V <sub>CTRL</sub> )	-10	V <sub>DC</sub>
RF Input Power	+30	dBm
Storage Temperature	-40 to +150	°C
Operating Temperature	-40 to +85	°C
ESD JESD22-A114 Human Body Model (HBM)	Class 1A (All Pads)	



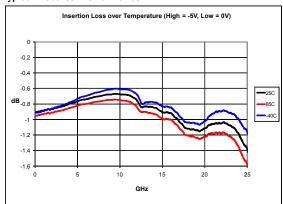
Caution! ESD sensitive device.

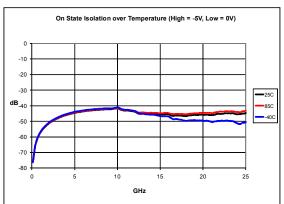
Exceeding any one or a combination of the Absolute Maximum Rating conditions may cause permanent damage to the device. Extended application of Absolute Maximum Rating conditions to the device may reduce device reliability. Specified typical performance or functional operation of the device under Absolute Maximum Rating conditions is not implied.

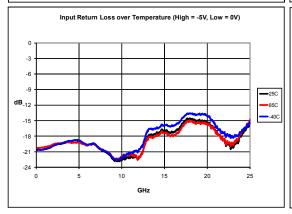
RoHS status based on EUDirective 2002/95/EC (at time of this document revision).

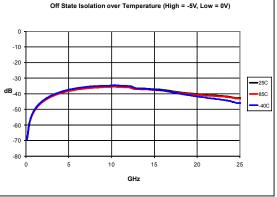
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### **Typical Electrical Performance**



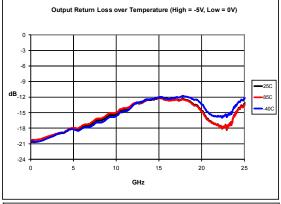


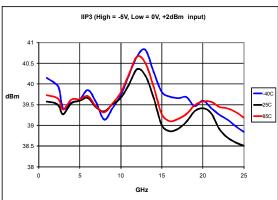


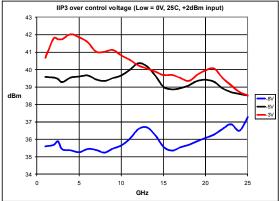


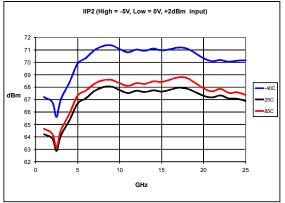


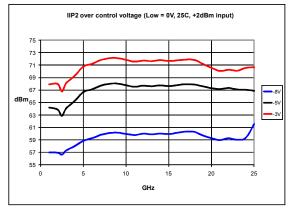






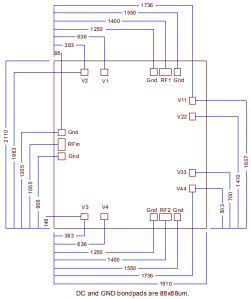








# **Die Layout**



RF bondpads are 88x150um.

All units are in um.



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Pin	Function	Description	Interface Schematic
1	RFIN	RF input. This pad is DC coupled and matched to $50\Omega$ from DC to $20$ GHz. $50\Omega$ microstrip transmission line on $0.127$ mm (5 mil) thich alumnia thin film substrate is recommended.	RFIN O
2	RF1, RF2	RF output. This pad is DC coupled and matched to $50\Omega$ from DC to $20$ GHz. $50\Omega$ microstrip transmission line on $0.127$ mm (5 mil) thich alumnia thin film substrate is recommended.	RFout
3	V1, V2, V3, V4	DC control pad for switch operation. Nominal operating voltage is -5V.	2kohm 5pF
4	V11, V22, V33, V44	Alternate bonding locations for V1, V2, V3, V4.	
5	GND	Provides ground path for probe measurements.	

### **Truth Table**

	RF Path			
V1	V2	V3	V4	
High	Low	High	Low	RFIN - RF1
Low	High	Low	High	RFIN - RF2
Low	High	High	Low	OFF (High Isolation)

High=-3V to -8V (-5V nominal), Low=0, ±0.2V



#### Measurement Technique

All specifications and typical performances reported in this document were based on data taken with the equipment listed in the stated manner.

Data was taken using a temperature controlled probe station utilizing 150um pitch GSG probes. The probes were placed on a ceramic coplanar to microstrip launch. The launch was then wire bonded to the die using two 1 mil bondwires. The spacing between the launch and the die was 200um, and the bondwire loop height was 100um. the thickness of the test interface was 125um (5mil).

The calibration included the probes and test interfaces, so that the measurement reference plane was at the point of bondwire attachment. Therefore, all data represents the part and accompanying bondwires.

Insertion Loss, Return Loss, and Isolation data were taken using an Agilent E8363B PNA.

IIP3 and IIP2 data were taken utilizing a pair of Agilent E8257D signal generators and an Agilent E4446A PSA.

#### **Preferred Assembly Instructions**

GaAs devices are fragile and should be handled with great care. Specially designed collets should be used where possible. The back of the die is metallized and the recommended mounting method is by the use of conductive epoxy. Epoxy should be applied to the attachment surface uniformly and sparingly to avoid encroachment of epoxy onto the top face of the die. Ideally it should not exceed half the chip height. For automated dispense Ablestick LMISR4 is recommended and for manual dispense Ablestick 84-1 LMI or 84-1 LMIT are recommended. These should be cured at a temperature of  $150\,^{\circ}\text{C}$  for one hour in an oven especially set aside for epoxy curing only. If possible the curing oven should be flushed with dry nitrogen. The gold-tin (80% Au 20% Sn) eutectic die attach has a melting point of approximately  $280\,^{\circ}\text{C}$  but the absolute temperature being used depends on the leadframe material used and the particular application. The time at maximum temperature should be kept to a minimum. This part has gold (Au) bond pads requiring the use of gold (99.99% pure) bondwire. It is recommended that  $25.4\,\text{um}$  diameter gold wire be used. Recommended lead bond technique is thermocompression wedge bonding with  $0.001^{\circ}$  ( $25\,\mu\text{m}$ ) diameter wire. Bond force, time stage temperature, and ultrasonics are all critical parameters and the settings are dependent on the setup and application being used. Ultrasonic or thermosonic bonding is not recommended. Bonds should be made from the die first and then to the mounting substrate or package. The physical length of the bondwires should be minimized especially when making RF or ground connections.

#### **Handling Precautions**

To avoid damage to the devices, care should be exercised during handling. Proper Electrostatic Discharge (ESD) precautions should be observed at all stages of storage, handling, assembly, and testing.

#### **ESD/MSL Rating**

These devices should be treated as Class 1A (250V to 500V) using the human body model as defined in JEDEC Standard No. 22-A114. Further information on ESD control measures can be found in MIL-STD-1686 and MIL-HDBK-263. This is an unpackaged part and therefore no MSL rating applies.

## **Ordering Information**

Part Number	Description	Delivery Method	Quantity		
RFSW2041DS2	DC to 25GHZ GaAs SPDT Switch	Waffle Pak	2 pc		
RFSW2041DSB	DC to 25 GHz GaAs SPDT Switch	Waffle Pak	5 pc		
RFSW2041DSQ	DC to 25 GHz GaAs SPDT Switch	Waffle Pak	25 pc		
RFSW2041D	DC to 25 GHz GaAs SPDT Switch	Waffle Pak	100 pc		